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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known

Application Number	09/583,087
Filing Date	September 5, 2000
First Named Inventor	Shunpei YAMAZAKI
Group Art Unit	2815
Examiner Name	J. Jackson, Jr.
Attorney Docket Number	0756-2203

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Code ²	Kind (if known)			
		5,289,300		Shunpei YAMAZAKI et al.	02/22/1994	

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Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
		JP	04-042214		Shimone	02/12/1992		Abstract
		JP	04-186635		Sato	07/03/1992		Abstract

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Lewis et al., "Active Matrix Liquid Crystal Display Design Using Loa and High Temperature Processed Polysilicon TFTS", 1990, pp. 843-846, IEEE Ch. 2865, 34.1.1, IEDM 90	

Examiner Signature	Date Considered	10/01
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Applicants: Shunpei YAMAZAKI

Filing Date: September 05, 2000

Group Art Unit:
Unassigned

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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	62-115745	05/27/1987	JP			Eng Abst	

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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				Applicant: Shunpei YAMAZAKI			
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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				Applicant: Shunpei YAMAZAKI	
				Filing Date: September 5, 2000	
OFFICE OF PETITIONS				Group:	
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*Reference cited in parent application S.N. 08/962,601

Form PTO-1449
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						Yes	No
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	64-68728*	03/1989	JP			Abstract	
	1-107237*	04/1989	JP				X
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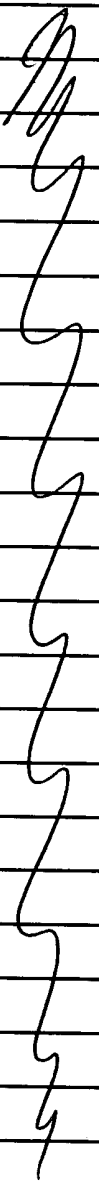
Applicant: Shunpei YAMAZAKI

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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Examiner <i>J. Jordan</i>	Date Considered <i>10/01</i>
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Atty Docket 075 203

Serial No. 09/583,087

INFORMATION DISCLOSURE STATEMENT

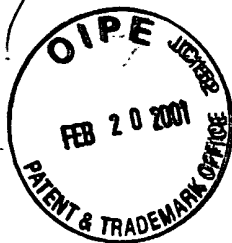
Applicants: Shunpei YAMAZAKI

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Unassigned

FOREIGN PATENT DOCUMENTS

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						Yes	No
<i>[Signature]</i>	60-138909	07/23/1985	JP			Full Eng	
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